

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

|                                 |   |                                |
|---------------------------------|---|--------------------------------|
| In re Patent Application of:    | ) | Confirmation No. 2927          |
| Osamu Nakamura                  | ) |                                |
| Application No. 10/807,472      | ) | Examiner: Rakesh Kumar Dhingra |
| Filed: March 24, 2004           | ) | Group Art Unit: 1763           |
| For: PLASMA TREATMENT APPARATUS | ) |                                |
|                                 | ) | Date: March 12, 2007           |

**AMENDMENT**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 11, 2006, please amend the above-captioned application as follows: